

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Joseph McCrossan et al.

Serial No.: 10/561,418

Filed: December 19, 2005

For: RECORDING MEDIUM,  
REPRODUCTION APPARATUS,  
RECORDING METHOD,  
INTEGRATED CIRCUIT,  
PROGRAM, AND  
REPRODUCTION METHOD

Patent Examiner:

Group Art Unit: 2622

Confirmation No.: 6754

March 15, 2007

Costa Mesa, California 92626

**SUPPLEMENTAL  
INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents  
PO Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In an attempt to fully comply with the duty of disclosure set forth in 37 C.F.R. § 1.56 and in conformance with 37 C.F.R. §§ 1.97 and 1.98, applicant wishes to bring to the attention of the U.S. Patent Office the following reference, which was found during the prosecution of a co-pending Japanese patent application:

Japanese Patent Application Publication No. 2003-116100 and corresponding family application:

US Publication Application No. 2003/0086568.

A copy of the foreign reference and form PTO-A820 are attached.

The undersigned attorney hereby certifies that each item of information contained in the information disclosure statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing the information

disclosure statement.

If the Examiner believes that a telephone conference would help further the prosecution of this case, he is respectfully requested to contact the undersigned attorney at the listed telephone number.

Very truly yours,

SNELL & WILMER LLP



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<b>INFORMATION DISCLOSURE CITATION</b> <i>(Use several sheets if necessary)</i>				<b>Docket Number (Optional)</b> <b>92478-8500</b>		<b>Application Number</b> <b>10/561,418</b>		
				<b>Applicant(s)</b> <b>Joseph McCrossan et al.</b>				
				<b>Filing Date</b> <b>December 19, 2005</b>		<b>Group Art Unit</b> <b>2622</b>		
<b>U. S. PATENT DOCUMENTS</b>								
<b>EXAMINER INITIAL</b>	<b>REF</b>	<b>DOCUMENT NUMBER</b>	<b>DATE</b>	<b>NAME</b>	<b>CLASS</b>	<b>SUBCLASS</b>	<b>FILING DATE IF APPROPRIATE</b>	
<b>U.S. PATENT APPLICATION PUBLICATIONS</b>								
<b>EXAMINER INITIAL</b>	<b>REF</b>	<b>DOCUMENT NUMBER</b>	<b>DATE</b>	<b>NAME</b>	<b>CLASS</b>	<b>SUBCLASS</b>	<b>FILING DATE IF APPROPRIATE</b>	
		20030086568	5.8.2003	Kato et al.				
<b>FOREIGN PATENT DOCUMENTS</b>								
	<b>REF</b>	<b>DOCUMENT NUMBER</b>	<b>DATE</b>	<b>COUNTRY</b>	<b>CLASS</b>	<b>SUBCLASS</b>	<b>Translation</b>	
		2003-116100	4.18.2003	Japan (See US Patent Application No. 2003/0086568)			<b>YES</b>	<b>NO</b>
<b>OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)</b>								
<b>EXAMINER</b>				<b>DATE CONSIDERED</b>				
<b>EXAMINER:</b> Initial if citation considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.								